IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

h re application of: David Wallman

Attorney Docket No.: SUN1P287/P4990

Application No.: 09/752,886

Examiner: Filipczyk, M.

Filed: December 28, 2000

Group: 2171

Title: METHODS AND APPARATUS FOR **OPTIMIZING GARBAGE COLLECTION**

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. sufficient postage as first-class mail on

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INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 MAR 0 9 2004

Technology Center 2100

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing Office Action on the merits, or (III) Constituted Examination.

Action after the filing of a Request for Continued Examination.

believed that no fees are due in connection with the filing of this Information Disclosure.

Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. SUN1P287). date of the above-referenced application, (ii) believed to be filed before the mailing date of a first

Respectfully submitted,

BEYER WEAVER & THOMAS, LLP

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Information Disclosure Statement By Applicant Atty Docket No. SUN1P287/P4990

Application No.: 09/752,886

Applicant:

David Wallman

Filing Date **December 28, 2000**

Group **2171**

(Use Several Sheets if Necessary)

U.S. Patent Documents

Examiner						Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
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Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	Translation	
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No	
	L								
	M								

Other Documents

Examiner					
Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication			
	N				
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	<u> </u>				
Examiner		Date Considered			
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.